What is claimed is:

1. An arrangement for debris reduction in a radiation source based on a plasma comprising:

a radiation-generating plasma, as source location;

collector optics;

a debris filter being arranged between said radiation-generating plasma and collector optics; and

exchangeable additional optics being arranged in the radiation path between the debris filter and the collector optics, wherein a distance-increasing intermediate imaging of the source location relative to the collector optics is provided by the additional optics for further debris reduction.

- 2. The arrangement according to claim 1, wherein the additional optics are reflection optics.
- 3. The arrangement according to claim 2, wherein the additional optics have reflecting surfaces for reflection in grazing incidence.
- 4. The arrangement according to claim 3, wherein the reflecting surfaces of the additional optics are shaped as curved surfaces of revolution.
- 5. The arrangement according to claim 4, wherein the reflecting surface has the shape of an ellipsoid of revolution.
- 6. The arrangement according to claim 4, wherein the reflecting surface has the shape of a paraboloid of revolution.
- 7. The arrangement according to claim 4, wherein the reflecting surface has the shape of a hyperboloid.

- 8. The arrangement according to claim 4, wherein the additional optics comprise a combination of a plurality of reflecting surfaces with differently curved surfaces of revolution.
- 9. The arrangement according to claim 3, wherein the reflecting surfaces of the additional optics are made of metal which is highly reflective in the EUV region.
- 10. The arrangement according to claim 9, wherein the reflecting surfaces of the additional optics are incorporated in highly reflective metallic base material.
- 11. The arrangement according to claim 9, wherein the reflecting surfaces of the additional optics are coated with a highly reflective metallic coat.
- 12. The arrangement according to claim 9, wherein the reflecting surfaces of the additional optics contain at least one of the metals, molybdenum, rhodium or palladium.